



Docket No.: S8810.0003/P003
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi Kawasaki et al.

Application No.: 10/588,283

Confirmation No.: N/A

Filed: August 4, 2006

Art Unit: Not Yet Assigned

For: METHOD OF MANUFACTURING THIN
FILM, METHOD OF MANUFACTURING p-
TYPE ZINC OXIDE THIN FILM AND
SEMICONDUCTOR DEVICE

Examiner: Not Yet Assigned

FIRST PRELIMINARY AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 5 of this paper.